

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. P107242-00019	SERIAL NO. New Application
LIST OF REFERENCES CITED BY APPLICANT <i>(Use several sheets if necessary)</i>		APPLICANT TAMATSUKA	
		FILING DATE July 9, 2001	GROUP

## U.S. PATENT DOCUMENTS

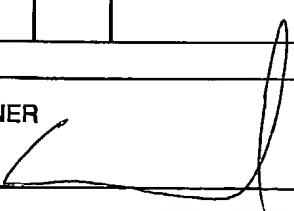
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
AA						
AB						
AC						
AD						
AE						
AF						

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO PART
AG						
AH						
AI						
AJ						
AK						
AL						

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AM	Abstract of Japanese Patent Publication No. 11195565A; dated July 21, 1999
	AN	"Dynamic Behavior of Intrinsic Point Defects in FZ and CZ Silicon Crystals," Mat. Res. Soc. Symp. Proc. Vol. 262, 1992 Materials Research Society, ABE et al., pp. 3-13
	AO	

EXAMINER	DATE CONSIDERED
	8/18/01

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.